

Docket No.: 123056-0500443

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of :  
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Sun Jin YUN et al. : Confirmation No. 4540  
:   
U.S. Patent Application No. 10/777,102 : Group Art Unit: 2815  
:   
Filed: February 13, 2004 : Examiner: DIAZ, JOSE R  
  
For: Substrate with microstructure formed thereon and manufacturing method thereof

**AMENDMENT**

**MAIL STOP AMENDMENT**  
COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria VA 22313-1450

Sir:

The following amendments and remarks are submitted in response to the Official  
Action dated *January 12, 2007*.